



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 15, 2026	
IGI Report Number	LG817680880
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE CUSHION MODIFIED BRILLIANT
Measurements	8.48 X 8.09 X 5.42 MM

GRADING RESULTS

Carat Weight	3.03 CARATS
Color Grade	E
Clarity Grade	VVS 2

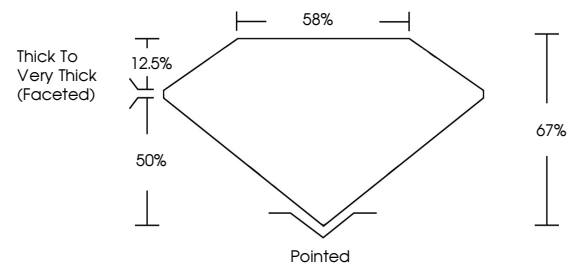
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG817680880

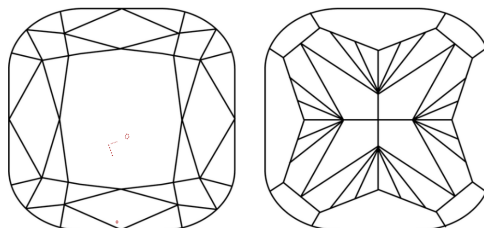
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG817680880
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

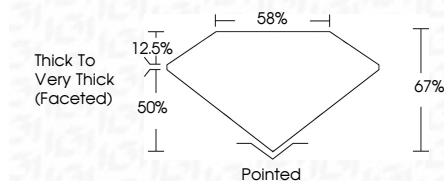
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

July 15, 2026	Report No. LG17160080	Color Grade	WVS 2	Polished	Comments:
	Square cushion modified brilliant	Carat Weight	0.75	Excellent	The Laboratory Grown Diamond was
	4.48 X 4.05 X 4.42 MM	3.03 Carats	55%	Excellent	created by Chemical Vapor Deposition
			Thick to Very Thick (faceted)	None	(CVD) growth process.
				681 LG17160080	Type IIa